



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9616**  
Koji MISHIMA et al. : **Docket No. 2001-1323A**  
Serial No. 09/955,115 : **Group Art Unit 1741**  
Filed September 19, 2001 : **Examiner Wong, Edna**

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4/11/03

PLATING METHOD AND PLATING APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents,  
Washington, D.C.

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

This is in response to the Restriction Requirement of March 12, 2003.

Applicants, by their undersigned representative, hereby elect the invention of Group I which is drawn to a plating method and corresponds to claims 1-6.

Having made the required election, a full examination on the merits of the elected invention is hereby requested.

Respectfully submitted,

Koji MISHIMA et al.

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